

## Experiment Report Form



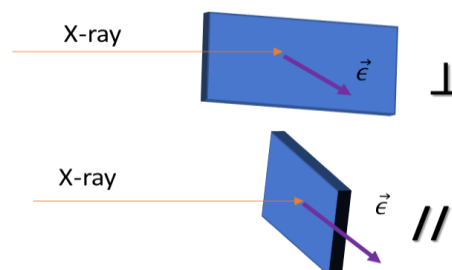
<b>Experiment title:</b> <i>Local Atomic structure in SiGeSn epitaxial thin films</i>	<b>Experiment number:</b> <b>MA-5463</b>
<b>Beamline:</b> BM08	<b>Date of experiment:</b> from: 02.02.2023 to: 07.02.2023
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### Report:

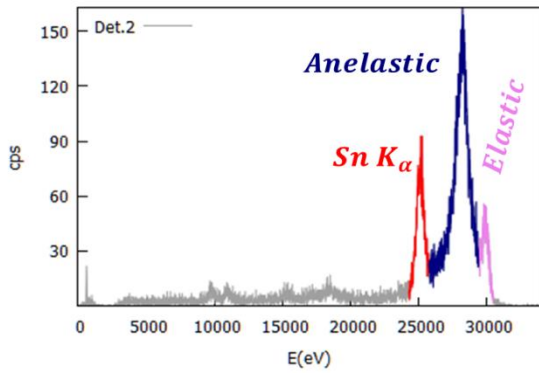
The proposal is aimed at obtaining a systematic description of Sn local structure in  $\text{Ge}_{1-x}\text{Sn}_x$  thin films grown in  $\text{Ge}_{1-y}\text{Si}_y$  virtual substrates.

We measured the Sn K edge XAFS spectra on 15 thin film samples as a function of film thickness (30-700 nm), Sn content ( $x = 5\% - 26\%$ ), deposition method (CVD, MBE) and substrate temperature. Some sample has been measured with the x-ray polarization oriented nearly parallel (about  $10^\circ$ ) and nearly perpendicular (about  $80^\circ$ ) to the film plane (Fig. 1).

Sn K-edge x-ray absorption spectra were collected in fluorescence geometry keeping the samples at the LN temperature. Total fluorescence yield was collected using ultrapure-Ge multidetector (8 detectors), the substrate Ge fluorescence was attenuated using 3mm Al filter in front of the detector, the total counts per diode was kept less than  $9 \times 10^4$  cps to keep the detector deadtime less than 5% and reduce not linearity effects. The Sn  $\text{K}\alpha$  fluorescence was selected using the MCA electronics. **The major limitation to the signal statistics was the intense anelastic signal from the background representing about 90% of the total fluorescence on the detectors.**

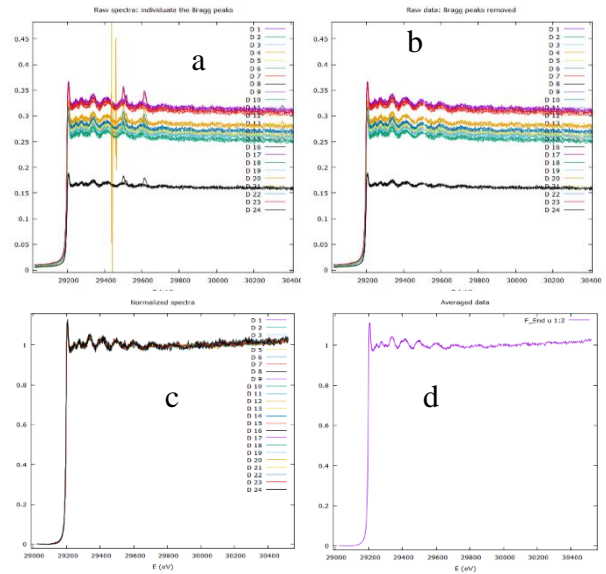


**Fig. 1** Geometry for polarization dependent measurements



**Fig. 3:** Procedure for data treatment: **a.** the raw Sn K edge XAS spectra: 3 scans, 8 detectors/scan, measured rotating the sample by 0.5 deg. each, **b.** raw data from which the regions of the Bragg peaks are removed, **c.** the raw data are normalized, and **d.** averaged.

**Fig. 2:** MCA output from one of the Ge detectors, the **Elastic** (cyan), **Compton** (blue) and **Sn K<sub>α</sub>** (red) contributions are highlighted.

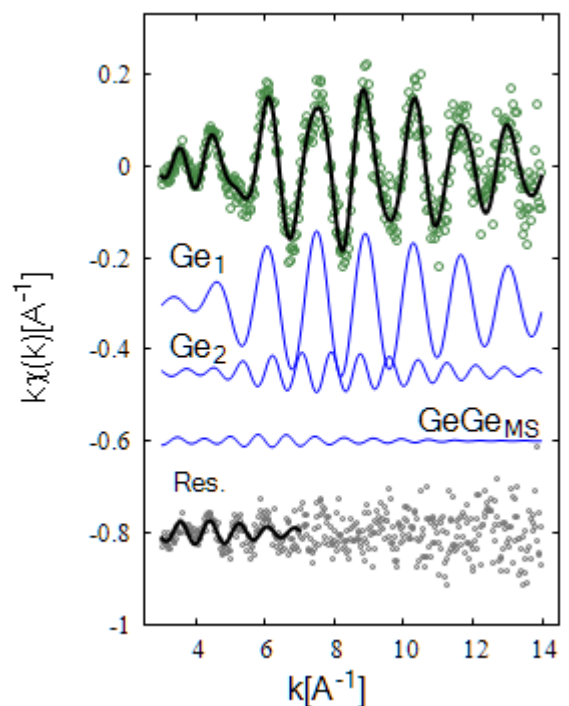


To improve the data statistics and remove the Bragg peaks from the substrate each scan was repeated 3-4 times tilting the sample by some  $10^{-1}$  deg. This allows to individuate and remove the Bragg peaks as shown in fig. 3 with a procedure we implemented via Python script. Data collection required in average 6-7 hours per sample/polarization.

We obtained good quality spectra (estimated noise on the averaged spectra is around  $5 \times 10^{-3}$  of the Jump discontinuity) up to  $k = 14-15 \text{ \AA}^{-1}$ .

The preliminary analysis on the thicker (700 nm) CVD deposited sample ( $x=0.11$ ) has been carried out assuming Sn atoms isolated in Ge lattice, considering two single scattering shells,  $\text{Ge}_1$  and  $\text{Ge}_2$  plus the multiple scattering contribution  $\text{Sn-Ge}_1\text{-Ge}_2$  as shown in fig. 4. The  $\text{Sn-Ge}_1$  bond length around  $2.6 \text{ \AA}$  indicates about 6% dilated Sn-Ge bond respect to pure Ge (being the Ge-Ge bond length  $2.45 \text{ \AA}$ ). The  $\text{Sn-Ge}_2$  distance is found around  $4.1 \text{ \AA}$ , 2.5% longer than Ge-Ge<sub>2</sub> distance in pure Ge.

The best fit also points out a structural residue evident in the low  $k$  region but masked by the statistical noise above  $k \sim 8 \text{ \AA}^{-1}$ . The preliminary analysis suggests this residue related to Sn-Sn contribution originating from not random Sn distribution in the Ge network. We must stress here that the data statistics here obtained is the best obtainable with the setup used at BM08 in a reasonable acquisition time (6-7 hours per averaged spectrum). To improve the data quality keeping a reasonable collection time, a detection set-up based on crystal analysers would be suitable.



**Fig. 4:** Sn K edge multi-shell EXAFS data analysis in  $k$  space (left panel): the experimental (green dots) data and best fit (black line) are presented at the top, partial contributions (blue) are shown below, shifted for clarity. The residual (exp-best fit) is presented at the bottom. In black is evident a structured residue indicating a structural contribution different from that Sn impurity in Ge phase.